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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/651,277  
Filing Date: 08/28/2003  
Applicant: Yoshifumi Okabe, et al.  
Group Art Unit: 2811  
Examiner: Steven Loke  
Title: SEMICONDUCTOR DEVICE AND METHOD OF  
MANUFACTURING SAME  
Attorney Docket: 4041J-000499/DVE

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Mail Stop Amendment  
Director of The United States Patent and Trademark Office  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

**AMENDMENT**

Sir:

In response to the Office Action mailed September 24, 2004, Paper No./Mail Date 20040919, please amend and reconsider the above referenced patent application as follows.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** begin on page 3 of this paper.

**Remarks** begin on page 5 of this paper.